# Process Variation Analysis for MEMS Design * 

Luca Schenato, Wei-Chung Wu, Laurent El Ghaoui and Kristofer Pister<br>Department of Electrical Engineering and Computer Sciences<br>University of California at Berkeley<br>Berkeley, CA 94720-1770, U.S.A.<br>\{lusche|wcwulelghaouilpister\}@eecs.berkeley.edu

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#### Abstract

Process variations, incurred during the fabrication stage of MEMS structures, may lead to substantially different performance than the nominal one. This is mainly due to the small variation of the geometry of the structure with respect to the ideal design. In this paper we propose an approach to estimate performance variations for general planar suspended MEMS structure for low frequency applications. This approach is based on two complementary techniques, one probabilistic and the other deterministic. The former technique, based on the Monte-Carlo method, defines a random distribution on the geometric variables and evaluates the possible outcome performance by sampling that distribution. The latter technique, based on robust optimization and semidefinite programming (SDP) approximations [5], finds bounds on performance parameters given the bounds on the geometric variables, i.e. it considers the worst case scenario. Both techniques have been integrated with SUGAR, a simulation tool for MEMS devices available to the public [4] [2], and tested on different types of folded springs.


Index Terms-Process variation, CAD, nodal analysis, Monte Carlo algorithm, robust optimization, SDP, performance bounds.

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## 1 Introduction

MEMS is a fast growing research area enabled by microfabrication of sensors, actuators, and electronics. Fine line lithography and high yield processing make it possible to create complex systems composed of dozens to millions of devices. Several MEMSCAD tools are appearing to help the design both at the device-level [11] [15] [9] and at the system-level [13] [6].

However, most of them cannot take into account possible variation of design after fabrication process, which may lead to non negligible effect on the overall structure behavior.

Our intent is to address this issue by estimating bounds on the variation of performance specifications arising from process variation in the geometric design variables.

There are several methods intended to deal with the problem of optimization with uncertain data. The stochastic approach models uncertainties as random variables, such as in the Monte-Carlo algorithms [10], and gives estimates of the probability distribution on the performance parameters. The robust optimization approach, instead, tries to estimate the worst case among infinite number of scenarii. In our context, the latter approach means computing the smallest ellipsoid that encloses all possible performance parameter outcomes [7].

They are not mutually exclusive, and the designer should be given the possibility to choose between them, depending on the application. For example, the ellipsoidal calculus is particularly suited for safety critical application, but may be overconservative for some applications.

Both of these methods have been implemented and integrated into SUGAR1.0, a MEMS simulation software developed at UC Berkeley [4] and publicly available [2].

The next section describes the model adopted for planar suspended MEMS structure and describes the effect of process variation on the performance. Sections 3 and 4 describe the Monte-Carlo and the Ellipsoidal Calculus algorithms and their implementations. In the Section 5 several simulations are presented for common test structures. Finally, Section 6 offers some concluding remarks and proposes future extensions.

## 2 Model

We are following the same methodology adopted in SUGAR to analyze a surface micromachined MEM structure. This methodology is based on nodal


Figure 1: The atomic element description of a beam. The geometric variables, $L, w, t$, correspond to design variables. The displacements $x_{1}, y_{1}, \theta_{1}, x_{2}, y_{2}, \theta_{2}$ are related to the design specification and performance parameters.


Figure 2: A simple MEM structure where the nodes are explicitly enumerated
analysis: it decomposes the whole structure into atomic elements, such as beams, anchors, gaps, comb drives, whose behavior is described by a simple lumped dynamical system (Figure 1). Finally these atomic elements are connected together (Figure 2), giving rise to an internally coupled dynamical system. The displacements variables of each element are modeled by a nonlinear second order mechanical model as follows:

$$
\begin{equation*}
[m(\mathbf{x}, \mathbf{q})] \ddot{\mathbf{q}}+[d(\mathbf{x}, \mathbf{q}, \dot{\mathbf{q}})] \dot{\mathbf{q}}+[k(\mathbf{x}, \mathbf{q})] \mathbf{q}=\mathbf{f}(\mathbf{q}) \tag{1}
\end{equation*}
$$

where $\mathbf{q}=\left(x_{1}, y_{1}, \theta_{1}, x_{2}, y_{2}, \theta_{2}\right)^{T}$ is the vector of nodal displacements, and $\mathbf{x}=\left(L_{1}, w_{1}, t_{1}, E, \nu\right)^{T}$ is the vector of design variables, which corresponds to the geometric dimensions, ( $L_{1}, w_{1}, t_{1}$ ), the Young's modulus, $E$, and the Poisson ratio for the material, $\nu$. The matrices $[m],[d],[k]$ are respectively the effective mass, damping and spring stiffness of the dynamical system and they depend nonlinearly both on the design variables and on the displacement vector.

Since in this analysis we are considering only the DC equilibrium state, we can neglect the mass and damping term, simplifying Equation (1) as

$$
\begin{equation*}
[k(\mathbf{x}, \mathbf{q})] \mathbf{q}=\mathbf{f}_{\mathbf{D C}}(\mathbf{q}) \tag{2}
\end{equation*}
$$

For small displacements the force vector, $\mathbf{f}_{\mathbf{D C}}(\mathbf{q})$, and the stiffness matrix, $[k]$, are independent of $\mathbf{q}$. In this case the stiffness matrix, $[k]$, takes the following expression for a simplified planar view[4]:

$$
[k(\mathbf{x})]=\frac{E}{L^{3}}\left[\begin{array}{cccccc}
w t L^{2} & 0 & 0 & -w t L^{2} & 0 & 0  \tag{3}\\
0 & 12 I & 6 I L & 0 & -12 I & 6 I L \\
0 & 6 I L & 4 I L^{2} & 0 & -6 I L & 2 I L^{2} \\
-w t L^{2} & 0 & 0 & w t L^{2} & 0 & 0 \\
0 & -12 I & -6 I L & 0 & 12 I & -6 I L \\
0 & 6 I L & 2 I L^{2} & 0 & -6 I L & 4 I L^{2}
\end{array}\right]
$$

where $E$ is the Young's modulus for the beam and $I$ is the moment of inertia of the beam cross section given by:

$$
\begin{equation*}
I=\frac{t w^{3}}{12} \tag{4}
\end{equation*}
$$

Since each structure may have different orientations, all local coordinates are transformed into global coordinates by a rotation matrix, $T(\alpha)$, where $\alpha$ is the orientation of the beam measured counterclockwise from the positive $x$ axis [4]. The stiffness matrix in global coordinates is thus given by $[k]_{g l o b a l}=$ $[T]^{T}[k]_{\text {local }}[T]$.

The assemblage of the set of individual matrices $[k]$ into the collective system matrix, $[\mathrm{K}]$, and vectors $\mathbf{f}_{\mathbf{D C}}$ into $\mathbf{F}_{\mathbf{D C}}$, where all structures are coupled at common nodes, is accomplished by nodal superposition. Thus, the entire system DC equilibrium can be expressed as

$$
\begin{equation*}
[K(\mathbf{x})] \mathbf{q}=\mathbf{F}_{\mathbf{D C}} \tag{5}
\end{equation*}
$$

where the nodal displacement $\mathbf{q}=\left(x_{1}, y_{1}, \theta_{1}, \ldots, x_{n}, y_{n}, \theta_{n}\right)^{T}$ is the vector of all nodal displacements, and $\mathbf{x}=\left(L_{1}, w_{1}, t_{1}, \ldots, L_{n}, w_{n}, t_{n}\right)^{T}$ is the vector including all geometric design variables, and $\mathbf{F}_{\mathbf{D C}}$ is the vector of applied forces and torque. Note that this is a common linear equation of the form $A y=b$, if the geometry vector, $\mathbf{x}$, is fixed.

If $\mathbf{x}_{n o m}$ is fixed, the previous system has (in general) a unique equilibrium solution, $\mathbf{q}_{n o m}$, which can be efficiently computed by SUGAR. However, due to process variations the design variables may be slightly different from their nominal values, thus giving rise to different equilibrium solution. This phenomenon can be characterized mathematically by adding an unknown perturbation term, $\delta \mathbf{x}$, to the nominal value of the design variables, $\mathbf{x}_{\text {nom }}$, i.e. $\mathbf{x}=\mathbf{x}_{\text {nom }}+\delta \mathbf{x}$, where $\delta \mathbf{x}$ belongs to a know set $\mathcal{U}$. Therefore Equation (5) must be rewritten as


Figure 3: The shaded region corresponds to the set of possible equilibrium points due to process variation. Note that even if the nominal designed equilibrium belongs to this set, it is not generally centered in the "middle" of the solution set. Ellipsoidal calculus tries to find the smallest ellipsoid that encloses this set, thus giving bounds on displacement variations

$$
\begin{equation*}
\left[K\left(\mathbf{x}_{n o m}\right)+\Delta K\right] \mathbf{q}=\mathbf{F}_{\mathbf{D C}} \tag{6}
\end{equation*}
$$

where $K\left(\mathbf{x}_{n o m}\right)$ depends only on the nominal design vector and is thus known, while $\Delta K$ is the bounded and structured uncertainty in the stiffness that depends on the vector $\delta \mathbf{x}$. It is now clear that the Equation (6) maps the set $\mathcal{U}$ into the set of all possible displacements $\mathcal{Q}$, which , of course, include the vector $\mathbf{q}_{\text {nom }}$. Though this mapping seems harmless, it is very complex and not amenable to analytic solution.

One option to tackle this problem is to define a probability distribution for the vector $\delta \mathbf{x}$ and then to solve Equation (6) for many samples drawn from that distribution. This is the underlying idea of Monte-Carlo algorithms described in the next section.

Another possibility would be to calculate an ellipsoid of confidence which encloses all possible equilibrium points, $\mathbf{q}$, as shown in Figure 3. This approach is the basis of the Ellipsoidal Calculus method developed in [5] [7], This can be done via semidefinite-programming (SDP) as proposed in [3]. The main difficulty for this approach is finding an appropriate form for the matrix $\Delta K$ in order to apply this algorithm. This is discussed in Section 5.

## 3 Monte-Carlo Algorithm

In this approach, we modeled the process variation assuming $\delta \mathbf{x}$ to be a vector of independent random variables. Only the width and thickness vari-
ations are considered, since length is only slightly affected by process variation. Young's modulus, Poisson ratio, sidewall angles and stress are assumed to be constant in order to simplify the following derivations.

We allowed three different random distributions: 1) a uniform distribution in the interval $\left(x_{n o m}-\delta, x_{n o m}+\delta\right)$, where $\delta$ is a parameter defined by the user, 2) a Gaussian distribution with mean $x_{n o m}$ and variance $\delta$ ), 3) a uniform corner distribution where $x=x_{n o m} \pm \delta$ takes value only at the extremes of the interval.

The first two distributions are motivated by their ubiquitous use in modeling parameters variation in practical applications. The last distribution is interesting because it well models the worst case scenario for the performance parameters. For simplicity, in our simulations the uncertainty interval for $\delta$ is fixed for all the geometric variables.

Since the number of samples is finite, it is necessary to give probabilistic bounds on the estimates of performance. These bound are characterized by two parameters, the accuracy, $\epsilon$, and the confidence, $1-\eta$. Suppose, for example, that we have drawn $l$ samples and we have calculated the fraction of samples, $r_{l}$, which have a performance between $\pm \epsilon$ the nominal performance. Then, we can say that the true fraction of samples, $r$, satisfies the following relation [14]:

$$
\begin{equation*}
P\left[\left|r-r_{l}\right|>\epsilon\right]<2 \exp ^{-2 \epsilon^{2} l}=\eta, \tag{7}
\end{equation*}
$$

where $P$ stands for probability. Therefore, given any desired accuracy and confidence, we can find the minimum number of samples that must be drawn to achieve them, as follows:

$$
\begin{equation*}
l>-\frac{1}{2 \epsilon^{2}} \ln \left(\frac{\eta}{2}\right) \tag{8}
\end{equation*}
$$

## 4 Confidence Ellipsoid Algorithm

As mentioned above, a different approach consists in finding the smallest ellipsoid which includes all possible solutions, $\mathbf{q}$, of Equation (6), as shown in Figure 3. This can be done through the solution of an SDP problem as long as the matrix $\Delta K$ takes a particular form called linear fractional representation (LFR). A particular case of this representation is the affine representation, which has the following expression:

$$
\begin{equation*}
(K+L \Delta R) \mathbf{q}=\mathbf{F}_{\mathbf{D C}} \tag{9}
\end{equation*}
$$

where the matrices, $K, L$ and $R$, are constant and depend on the structure of the uncertainty, i.e. on how the geometric perturbation affects the system matrix. The matrix $\Delta=\left\{\operatorname{diag}\left(\delta_{1} I_{r_{1}}, \ldots, \delta_{m} I_{r_{m}}\right) \mid \delta \in \mathbf{R}^{m},\|\delta\|_{\infty} \leq 1\right\}$, where $m$ is the number of independent variables and $I_{r_{i}}$ is the identity matrix of size $r_{i}$.

These four matrices can be found easily by considering the local stiffness matrix (3). First, we assume that the length, $L$, does not vary. This is a reasonable assumption since the relative variation of $L$ is very small in comparison with the relative variation of the thickness, $t$, and of the width, $w$. Moreover the thickness, $t$, and the width, $w$, have maximum variation of $\pm \delta$. Then, we can notice that the elements of the matrix, $[k]$, depends only on the area, $A=w t$, and the moment of inertia, $I$, of the beam. If we consider these as independent variables, we can rewrite $[k]$ as follows:

$$
\begin{align*}
{[k] } & =\left[\begin{array}{cccccc}
\frac{E}{L} & 0 & 0 & -\frac{E}{L} & 0 & 0 \\
0 & 0 & 0 & 0 & 0 & 0 \\
0 & 0 & 0 & 0 & 0 & 0 \\
-\frac{E}{L} & 0 & 0 & \frac{E}{L} & 0 & 0 \\
0 & 0 & 0 & 0 & 0 & 0 \\
0 & 0 & 0 & 0 & 0 & 0
\end{array}\right] A+\left[\begin{array}{cccccc}
0 & 0 & 0 & 0 & 0 & 0 \\
0 & \frac{12 E}{L^{3}} & \frac{6 E}{L^{2}} & 0 & -\frac{12 E}{L^{3}} & \frac{6 E}{L^{2}} \\
0 & \frac{6 E}{L^{2}} & \frac{4 E}{L} & 0 & -\frac{6 E}{L^{2}} & \frac{2 E}{L} \\
0 & 0 & 0 & 0 & 0 & 0 \\
0 & -\frac{12 E}{L^{3}} & -\frac{6 E}{L^{2}} & 0 & \frac{12 E}{L^{3}} & -\frac{6 E}{L^{2}} \\
0 & \frac{6 E}{L^{2}} & \frac{2 E}{L} & 0 & -\frac{6 E}{L^{2}} & \frac{4 E}{L}
\end{array}\right] I \\
& =\left[k_{A}\right] A+\left[k_{I}\right] I \tag{10}
\end{align*}
$$

where the matrices, $\left[k_{A}\right]$ and $\left[k_{I}\right]$, are constant, and only the area, $A$, and the moment of inertia, $I$, may change due to process variations. Since the variables, $A$ and $I$, belong to an interval, it is more convenient to rewrite equation (10) in terms of the interval mean, $\bar{A}=\left(A_{\max }+A_{\min }\right) / 2$, and interval half-width, $d_{A}=\left(A_{\max }-A_{\min }\right) / 2$, as follows:

$$
\begin{align*}
{[k] } & =\bar{A}\left[k_{A}\right]+d_{A}\left[k_{A}\right] \delta_{A}+\bar{I}\left[k_{I}\right]+d_{I}\left[k_{I}\right] \delta_{I} \\
& =\left[k_{A 0}\right]+\left[k_{A 1}\right] \delta_{A}+\left[k_{I 0}\right]+\left[k_{I 1}\right] \delta_{I} \\
& =\left[k_{0}\right]+L_{A}\left(\delta_{A} I_{r_{A}}\right) R_{A}+L_{I}\left(\delta_{I} I_{r_{I}}\right) R_{I} \tag{11}
\end{align*}
$$

where the matrices, $\left[k_{A 0}\right]\left[k_{A 1}\right]\left[k_{I 0}\right]\left[k_{I 1}\right]$ and $\left[k_{0}\right]$, are constant. The variables, $\delta_{A}$ and $\delta_{I}$, may range in the interval $[-1,+1]$, giving rise to all possible scenarii. The matrix $\left[k_{0}\right]=\left[k_{A 0}\right]+\left[k_{I 0}\right]$, is the sum of the two mean matrices. The matrices $\left[k_{A 1}\right]=L_{A} R_{A}$ and $\left[k_{I 1}\right]=L_{I} R_{I}$, are obtained by running the singular value decomposition (SVD) on the matrices $\left[k_{A 1}\right]$ and $\left[k_{I 1}\right]$. Now, we can see from Equation (11), that the local uncertainty matrix
has an affine representation. The global affine representation is simply obtained by stacking all the matrices $L_{i}, \delta_{i}$ and $R_{i}$ into a single global matrix as in Equation (9).

The algorithm that computes the confidence ellipsoid from this representation is quite complex and it is described in [7]. We simply mention that it recasts the problem as a Semidefinite Programming (SPD) problem [3], which can be solved numerically by the LMITOOL toolbox in Matlab [8].

Note: Before concluding this section, we want to remark that the two variables $\delta_{A}$ and $\delta_{I}$ are not independent, since the area, $A$, and the moment of inertia, $I$, are strictly related. However, the assumption that they are independent, simply results in adding infeasible solutions. Therefore, the ellipsoid may be overpessimistic, i.e. there may be a gap between the set of feasible solutions and the ellipsoid boundary.

## 5 Simulations

In this section we present some simulations of the previous algorithms on several MEM structures. For the following simulations we chose the following parameters: $\delta=0.1 \mu m, \eta=0.01, \epsilon=0.09, l=328$. Most of the beams in these structures have minimum width and thickness in order to magnify the effect of process variations.

The following plots show comparison between only two performance variables for ease of visualization, but multiple comparisons are possible.

Figure (4) shows a simple dog-bone-shape suspension, which has 6 nodes, 5 beams, 10 states ( $q^{\prime} s$ ), 10 independent process variables ( $\delta^{\prime} s$ ). This structure is designed to be symmetric so that a force applied on the $y$-axis would generate a displacement only along the y-axis. However, due to variations of geometric variables, this is not true, as shown on the plots where for several samples the diplacement along the $x$-axis is nonzero. In the middle plot of Figure (4) are shown some possible displacement outcomes for Node 4 due to a uniform distribution. The ellipsoid of $100 \%$ confidence seems to be overpessimistic, however it is tight, in the sense that there exist some possible solutions which lie on its boundary, though they are very "unlikely". This is clear in the bottom plot, where we used a uniform corner distribution. In fact we can see that there are solution on the boundary. In the folded spring of Figure (5), instead, we chose a Gaussian distribution instead of a uniform distribution for the middle plot. This structures has 8 nodes, 7 beams, 20 states ( $q^{\prime} s$ ), 14 independent process variables $\left(\delta^{\prime} s\right)$. Another interesting property of the ellipsoid approach is that it also captures the


Figure 4: A Dog-bone-suspension where a force of $-100 \mu N$ is applied at Node 4 along the $y$-axis. Middle plot: uniform distribution. Bottom plot: uniform corner distribution


Figure 5: A folded spring where a force of $-100 \mu N$ is applied at Node 5 along the $y$-axis. Middle plot: uniform corner distribution. Bottom plot: '+' uniform distribution, ' $x$ ' Gaussian distribution. In general, not all the samples from a Gaussian distribution lie inside the confidence ellipsoid as in this particular example
correlation among different displacement variables, as shown in the bottom plot of Figure (5), even though this time the ellipsoid seems to be not so tight.

## 6 Conclusions

In this paper we have proposed and simulated two approaches to analyze the effect of process variations on performance design. These approaches are reasonably flexible, can be easily modified by the user and seem to give meaningful results. All the code used for the simulations has been adapted to run with SUGAR1.0 and can be downloaded following the instructions in [1]. Easy extensions of our work, would be the introduction of different geometric bounds, $\delta$ 's, for the variation of each geometric variable, the analysis process variations of the Young's modulus and the Poisson ratio for the material and the study of 3-Dimensional structures.

As already mentioned above, the Monte Carlo approach and the robust optimization approach are two complementary methods. The former is more suitable and computationally efficient when the probability distribution over the geometric variables is known and simple, and when the accuracy and confidence required are not too high. The latter, instead, is particularly appropriate and computationally efficient for safety critical applications since, given bounds on the geometric variables, it can calculate $100 \%$ confidence bounds with perfect accuracy, i.e. $\epsilon=\eta=0$, over the performance parameters in polynomial time with respect to the number of geometric variables $O\left(n^{5}\right)$ [12]. In the Monte-Carlo method, instead, the worst case scenario scales exponentially in the number of process variation variable, $m$, since it requires the solution of $l=2^{m}$ different scenarii. In our simulations this would correspond to $l=1024$ for the structure in Figure 4 and to $l=16384$ for the structure in Figure 4. These examples show how this approach becomes soon intractable also for simple structures. A limiting factor for the extensive use of Ellipsoidal Calculus algorithm is the computational time it requires, although polynomial. This is mainly due to the overhead arising from the implementation of a general purpose SDP solver. Future work must be directed in the solution of this problem.

Another interesting issue is understanding why the ellipsoid approach is sometimes loose: it may either depend on the Lagrange relaxation [7] or on the approximated affine representation in Equation (11). Moreover, we are currently extending the Ellipsoidal Calculus towards design synthesis, i.e. tuning the nominal geometric dimensions of the original MEM structure in
order to improve performance specifications in spite of process variation.

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